

In re: Rinehart et al.
Serial No.: 10/661,916
Filed: September 11, 2003
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In the Title:

Please amend the title as follows:

SYSTEMS ~~AND METHODS~~ FOR FABRICATING OPTICAL
MICROSTRUCTURES USING A CYLINDRICAL PLATFORM AND A
RASTERED RADIATION BEAM.

In the Specification:

Please amend the paragraph at Page 1, lines 2-11 as follows:

This application is related to Application Serial No. ~~10/661,916~~ 10/661,917 entitled *Systems and Methods For Mastering Microstructures Through a Substrate Using Negative Photoresist and Microstructure Masters So Produced* (~~Attorney Docket No. 9409-3~~) to the present inventors, filed concurrently, and Application Serial No. 10/661,974, entitled *Systems and Methods For Fabricating Microstructures By Imaging A Radiation Sensitive Layer Sandwiched Between Outer Layers, and Microstructures Fabricated Thereby* (~~Attorney Docket No. 9409-4~~) to the present inventors, also filed concurrently, both of which are assigned to the assignee of the present application, the disclosures of both of which are hereby incorporated herein by reference in their entirety as if set forth fully herein.